

**Search Notes**

Application/Control No.

10/725,381

Examiner

Heather A. Doty

Applicant(s)/Patent under  
Reexamination

LEE, HAN-CHOON

Art Unit

2813

**SEARCHED**

Class	Subclass	Date	Examiner
438	627	8/22/2005	HJ
438	629	8/22/2005	HJ
438	630	8/22/2005	HJ
438	683	8/22/2005	HJ

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST (BRS), see attached	8/22/2005	HJ
Scirus, search term: atomic layer deposition titanium silicon nitride	8/22/2005	HJ